

**Notice of References Cited**

Application/Control No.

09/865,802

Applicant(s)/Patent Under  
Reexamination  
SEIBEL ET AL.

Examiner

Srirama Channavajjala

Art Unit

2177

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,434,544	08-2002	Bakalash et al.	707/2
	B	US-6,055,510	04-2000	Henrick et al.	705/14
	C	US-6,557,008	04-2003	Temple et al.	707/104.1
	D	US-6,477,536	11-2002	Pasumansky et al.	707/102
	E	US-6,029,141	02-2000	Bezos'et al.	705/27
	F	US-6,154,766	11-2000	Yost et al.	709/201
	G	US-6,651,055	11-2003	Kilmer et al.	707/3
	H	US-6,574,619	06-2003	Reddy et al.	707/2
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	WO 00/23929	04-2000	PCT	Alvin,RS	17/60
	O	WO 99/66446	12-1999	PCT	Tedesco et al.,	5/00
	P	WO 01/22692	03-2001	PCT	Jang et al.,	H04M
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.